

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	48	liu-hong-da	US-PGPUB; USPAT	OR	OFF	2005/07/28 16:13
S14	1	"6781652".pn.	US-PGPUB; USPAT	OR	OFF	2005/07/28 16:15
S20	5	(349/141.ccls. IPS-LCD IPS-LCDS) and ((rough roughness) with (nm nanometer micron angstrom ang))	US-PGPUB; USPAT	OR	ON	2005/07/28 16:25
S23	13	(349/141.ccls. IPS-LCD IPS-LCDS) and 349/113-115.ccls.	US-PGPUB; USPAT	OR	OFF	2005/07/28 17:32
S24	53	(349/141.ccls. IPS-LCD IPS-LCDS) and (reflect\$ near2 electrode)	US-PGPUB; USPAT	OR	OFF	2005/07/29 12:08
S25	3	349/113,114,141.ccls. and baur.in.	US-PGPUB; USPAT	OR	OFF	2005/07/29 12:09
S27	59	349/141.ccls. and (transflect\$ or (transmiss\$ near3 reflect\$))	US-PGPUB; USPAT	OR	OFF	2005/07/29 12:12
S28	10	349/113-115,141.ccls. and 349/107.ccls.	US-PGPUB; USPAT	OR	OFF	2005/07/29 12:13
S29	1738	349/113-115.ccls. not ((rough roughness) with (nm nanometer micron angstrom ang))	US-PGPUB; USPAT	OR	ON	2005/07/29 13:02
S22	26	349/113-115.ccls. and ((rough roughness) with (nm nanometer micron angstrom ang))	US-PGPUB; USPAT	OR	ON	2005/07/29 13:02
S31	40	"349".clas. and (comb comb-shaped) with reflect\$3	US-PGPUB; USPAT	OR	ON	2005/08/06 21:03
S33	10	(comb comb-shaped) with reflect\$3 and (liquid adj crystal)	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/06 21:05
S35	28	(rough roughness) and reflect\$3 and (liquid adj crystal) and (IPS in-plane parallel horizontal)	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/06 21:06
S13	5	liu-hong-da and @pd>"20050524"	US-PGPUB; USPAT	OR	OFF	2005/08/06 21:11
S37	12	((reflect\$3 transmiss\$3) adj region) same ((in adj plane) IPS)	US-PGPUB; USPAT	OR	OFF	2005/08/06 21:47
S40	143	349/141.ccls. and contact adj hole	USPAT	OR	ON	2005/08/06 21:53
S39	298	349/141.ccls. and contact adj hole	US-PGPUB; USPAT	OR	ON	2005/08/06 21:53
S38	27	((reflect\$3 transmiss\$3) adj region) and 349/141.ccls.	US-PGPUB; USPAT	OR	OFF	2005/08/06 21:53
S41	120	349/141.ccls. and (contact adj hole) with (pixel common)	USPAT	OR	ON	2005/08/06 21:54
S42	98	349/141.ccls. and (contact adj hole) with ((pixel common) adj electrode)	USPAT	OR	ON	2005/08/06 21:55

S43	3	("5671027" "5959708" "5969782").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/08/06 21:58
S44	7	("5786876" "5847781" "5852485" "5892562" "5995182" "5995187" "6014190").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2005/08/06 22:01
S46	78	349/141.ccls. and bent	USPAT	OR	OFF	2005/08/06 22:34
S50	15	"349".clas. and diffuser with color adj filter with polarizer	US-PGPUB; USPAT	OR	OFF	2005/08/06 22:39
S51	2	349/141.ccls. and diffuser with (color adj filter) with polariz\$3	US-PGPUB; USPAT	OR	OFF	2005/08/06 22:40
S52	3	349/141.ccls. and diffuser with (color adj filter)	US-PGPUB; USPAT	OR	OFF	2005/08/06 22:41
S55	5	349/112.ccls. and (color adj filter) and polariz\$3 and IPS	US-PGPUB; USPAT	OR	OFF	2005/08/06 22:42
S54	51	349/112.ccls. and (color adj filter) with polariz\$3	US-PGPUB; USPAT	OR	OFF	2005/08/06 22:42
S53	119	349/112.ccls. and (color adj filter) and polariz\$3	US-PGPUB; USPAT	OR	OFF	2005/08/06 22:42
S56	22	349/141.ccls. and (rough roughness)	US-PGPUB; USPAT	OR	OFF	2005/08/07 12:35
S26	866	349/141.ccls.	US-PGPUB; USPAT	OR	OFF	2005/08/07 12:35
S57	3	liu-hong-da and @pd>"20050806"	US-PGPUB; USPAT	OR	OFF	2006/02/07 16:47
S63	269	349/141.ccls. and reflect\$3	US-PGPUB; USPAT	OR	OFF	2006/02/07 16:58
S61	116	349/141.ccls. not reflect\$3 and (nm nanometer rough roughness)	US-PGPUB; USPAT	OR	OFF	2006/02/07 17:03
S62	578	349/141.ccls. not reflect\$3 not (nm nanometer rough roughness)	US-PGPUB; USPAT	OR	OFF	2006/02/07 17:05
S64	34	"349".clas. and (reflect\$3 and (nm nanometer micron) and (rough roughness uneven unevenness)). clm.	US-PGPUB; USPAT	OR	ON	2006/02/07 17:13
S69	6	349/113-115.ccls. and ((rough roughness) with (nm nanometer micron angstrom ang)) and @pd>"20050729"	US-PGPUB; USPAT	OR	OFF	2006/02/07 17:33
S65	181	349/46.ccls.	US-PGPUB; USPAT	OR	OFF	2006/02/08 11:26
L1	18	349/46.ccls. and 349/147.ccls.	US-PGPUB; USPAT	OR	OFF	2006/02/08 11:26
L3	192	349/147.ccls.	US-PGPUB; USPAT	OR	OFF	2006/02/08 12:36

AB 2/8/06